

ABSTRACT OF THE DISCLOSURE

A substrate K1 transported to a measurement position Pa by a substrate transport unit 10A is measured by a measuring head moved to a substrate-measuring position Qa by the drive 5 of a measuring head-moving unit. At the same time, a substrate K2 transported to an exposure position Rb by a substrate transport unit 10B is exposed by an exposure head moved to a substrate-exposing position Sb by the drive of an exposure head-moving unit. Then, the substrate K1 transported to an 10 exposure position Ra by the substrate transport unit 10A is exposed by the exposure head moved to a substrate-exposing position Sa by the drive of the exposure head-moving unit. At the same time, the next substrate K3 transported to a measurement position Pb by the substrate transport unit 10B 15 is measured by the measuring head moved to a substrate-measuring position Qb by the drive of the measuring head-moving unit.